

1634

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of

KAJIYAMA *et al.*

Application Number: 10/034,075

Filed: January 3, 2002

For: **ADVANCED THERMAL GRADIENT DNA
CHIP (ATGC), THE SUBSTRATE FOR
ATGC, METHOD FOR MANUFACTURING
FOR ATGC, METHOD AND APPARATUS
FOR BIOCHEMICAL REACTION,
AND STORAGE MEDIUM**

Attorney Docket No. HIRA.0021

Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231

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LETTER

Sir:

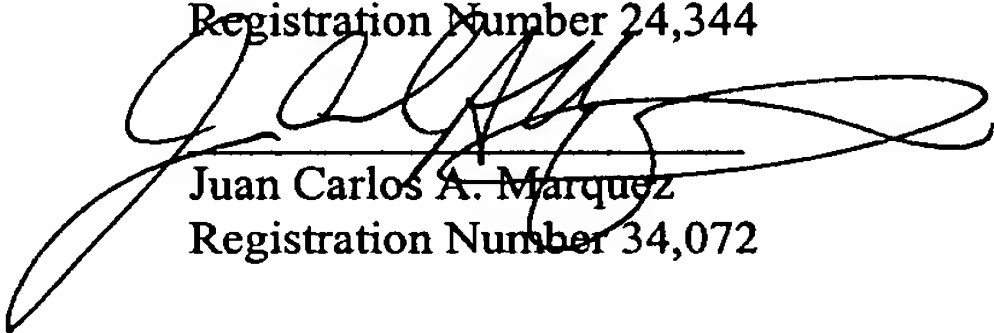
The below-identified communications are submitted in the above-captioned application or proceeding:

- | | |
|---|--|
| <input type="checkbox"/> ___ sheets of drawings | <input type="checkbox"/> Petition Requesting Consideration of IDS |
| <input type="checkbox"/> Letter to Draftsperson | <input checked="" type="checkbox"/> Information Disclosure Statement |
| <input type="checkbox"/> Response to Notice of | <input type="checkbox"/> Petition under 37 C.F.R. §1.47(a) |
| Non-Compliant Amendment | <input type="checkbox"/> Check for \$180.00 |

- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication, including fees under 37 C.F.R. § 1.16 and 1.17 or credit any overpayment to **Deposit Account Number 08-1480**. A duplicate copy of this sheet is attached.

Respectfully submitted,

Stanley P. Fisher
Registration Number 24,344



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3110 Fairview Park Drive
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(703) 641-4200
January 29, 2003

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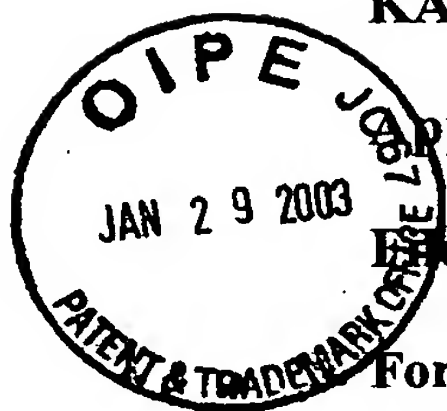
INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 C.F.R. §§ 1.56 and 1.97, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified, is submitted herewith.

CERTIFICATION

This Information Disclosure Statement is submitted after three months of the filing date but prior to the mailing date of the first Office Action of the above-captioned U.S. patent application. The reference was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. Accordingly, no fee is due or payable at this time.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.



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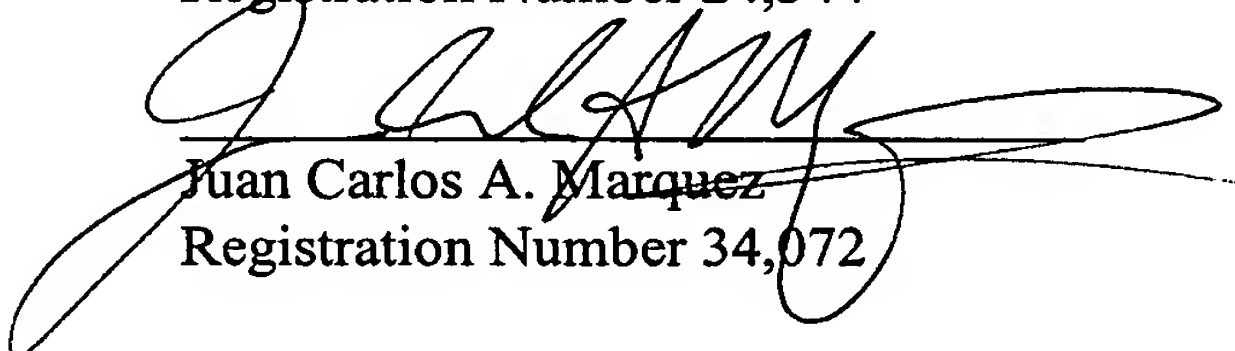
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Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 08-1480.

Respectfully submitted,

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Form PTO 1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	ATTY. DOCKET NUMBER HIRA.0021	SERIAL NUMBER 10/034,075
	APPLICANT KAJIYAMA et al	
	FILING DATE January 3, 2002	GROUP

U.S. Patent Documents

Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBC LASS	FILING DATE

Foreign Patent Documents

Examiner Initial	DOCUMENT NUMBER	FILING DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
						YES	NO
	11-127900	7/10/98	Japan			Abstract	X
	7-147982	11/29/93	Japan			Abstract	X
	5-317030	5/21/92	Japan			Abstract	X

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Other Documents (Including Author, Title, Date Pertinent Pages, Etc.)

	Office Action dated December 18, 2002 from Japanese Patent Office in Japanese.

